

<b>Notice of References Cited</b>	Application/Control No. 10/669,205	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Stanetta D. Isaac	Art Unit 2812	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0072039	04-2004	Jankowski et al.	429/019
	B	US-6,764,874	07-2004	Zhang et al.	438/99
	C	US-2004/0067604	04-2004	Ouellet et al.	438/108
	D	US-6,551,838	04-2003	Santini et al.	436/174
	E	US-6,500,694	12-2002	Enquist, Paul M.	438/109
	F	US-6,607,981	08-2003	Takahashi et al.	438/678
	G	US-6,406,636	06-2002	Vaganov, Vladimir I.	216/2
	H	US-2004/0137730	07-2004	Kim et al.	438/689
	I	US-2002/0028372	03-2002	Ohlsen et al.	429/40
	J	US-6,641,948	11-2003	Ohlsen et al.	429/44
	K	US-6,627,531	09-2003	Enquist, Paul M.	438/622
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.